

Subst. Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) SAM-0532		Application Number		
				Applicant Da -Hyuk Chung, t al.				
				Filing Date Herewith		Group Art Unit		
U. S. Patent Documents								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<i>AM</i>	AA	6,039,815	3/21/00	Yeol, et al.	134	2	3/26/97	
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<i>AM</i>	AL	JP 2-257632	90-10-03	Japan	H01L	21/00		X
	AM	JP 10-0242271	99-11-09	Japan	H01L	21/304		X
	AN	KR 01-0056346	01-07-04	Korea	H01L	21/304		X
<i>AM</i>	AO	JP 6-7233	94-01-18	Japan	A47F	3/04		X
	AP							
	AQ							
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
	AS							
	AT							
EXAMINER <i>A. MARCO</i>				DATE CONSIDERED <i>3/15/01</i>				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.								